

DOCKET NO: 250583US6 YA DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
SHINYA NISHIMOTO ET AL. : EXAMINER:
SERIAL NO: NEW APPLICATION :
FILED: HEREWITH : GROUP ART UNIT:
FOR: METHOD AND APPARATUS FOR AN IMPROVED OPTICAL WINDOW
DEPOSITION SHIELD IN A PLASMA PROCESSING SYSTEM

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VA 22314

SIR:

Prior to examination on the merits, please amend the above-identified patent
application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks begin on page 6 of this paper.